



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# 12/K  
1/15/02  
DOJ

Application Number: 09/519,165  
Filing Date: 03/06/2000  
Applicants: Sherrer, et al.  
Application Title: Single Mask Lithographic Process for Patterning Multiple Types of surface Features  
Examiner: William P. Watkin, III  
Art Unit: 1772  
Docket No.: ACT-111

Commissioner of Patents and Trademarks  
Washington, DC 20231

Sir:

**AMENDMENT A**

In response to the office action mailed 07/17/01, kindly amend the above application as follows:

**DRAWINGS:** No Changes

**SPECIFICATION:** No Changes

**CLAIMS:** Please amend claim 13. ✓  
Please add claims 19-29.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, DC 20231, on

1/16/01

Date of Deposit

Diane Hughes

Diane Hughes

1/16/01

Date